

Nano4me.org Video Download

ESC 212: Basic Nanotechnology Processes

Unit 5: Chemical Vapor Deposition



Lecture 1

Length: 55:48

This video will cover:

- Typical LPCVD Systems/Hardware
- Top-down Applications
- 2D Materials (Thin Films vs. Growth)

Thank You For Watching!

What did you think? [Email](#) Bob Ehrmann with your feedback.

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